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Docket No.: 2328-050A

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Jian J. CHEN et al.

U.S. Patent Application No. 10/647,347

Filed: August 26, 2003

For: INDUCTIVE PLASMA PROCESSOR METHOD

: : EXPEDITED PROCEDURE
: : Response under 37 CFR 1.116
: : Confirmation No. 3505

: : Group Art Unit: 1763

: : Examiner: Luz L. ALEJANDRO

AMENDMENT UNDER RULE 116

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is submitted in reply to the Office Action mailed September 1, 2006, which was made Final. Applicants respectfully request that the following amendments as to form be entered to place this application in condition for allowance.

CERTIFICATION OF FACSIMILE TRANSMISSION
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